



ITW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masahiro SAKURADA et al.

Group Art Unit: 1792

Application No.: 10/560,581

Examiner: HITESHEW, F.

Filed: February 2, 2006

Docket No.: 126274

For: A METHOD FOR PRODUCING A SINGLE CRYSTAL AND A SINGLE CRYSTAL

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR §1.97(i)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

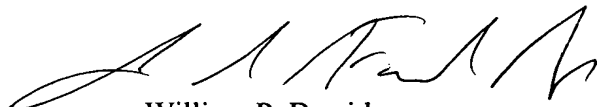
Sir:

In accordance with 37 CFR §1.97(i) and MPEP §609.05(a), Applicants submit the references listed on the attached PTO-1449.

- ☒ 1. Each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart application, and this communication was not received by any individual designated in §1.56(c) more than thirty days prior to the filing of this Information Disclosure Statement.
- ☒ 2. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- ☒ 3. An English language Abstract of one or more non-English language reference is attached. See References 2 and 3.
- ☒ 4. Reference 1 corresponds to reference 2.

It is requested that this Information Disclosure Statement and attached references be placed in the file of this application.

Respectfully submitted,



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Date: May 30, 2008

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